

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Jerome S. HUBACEK et al.

Application No.: 09/749,916

Filed: December 29, 2000

For: ELECTRODE FOR PLASMA PROCESSES AND METHOD FOR MANUFACTURE AND USE THEREOF

Mail Stop Amendment

Group Art Unit: 1763

Examiner: Luz L. Alejandro Mulero

Confirmation No.: 6834

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed November 29, 2004, for which the period for response has been extended to March 29, 2005 by the Petition for Extension of Time submitted herewith, please amend the above-identified patent application as follows: